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TECHNOLOGY CENTER 2800

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyki ABE et al.

Application No.: 08/930,449

Filed: October 7, 1997

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

# 311 August

Group Art Unit: 2814

Examiner: Shrinivas H. Rao

Docket No.: 039514

M. Brunson

SHC 4/9/03

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Entered  
7/31/03  
April

Sir:

In reply to the March 6, 2003 Office Action, please consider the following:

**Amendments to the claims; and**

**Remarks.**